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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

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Sheet

1

of

2

Application Number

10/687,562

**Filing Date**

10/16/2003

**First Named Inventor**

Cherala, et al.

### Group Art Unit

Unassigned

Examiner Name

Unassigned

Attorney Docket Number

PA61/UTS-35-01-03

## U.S. PATENT DOCUMENTS

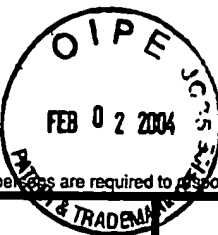
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Substitute for form 1449B/PTO		<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(use as many sheets as necessary)</i>		Application Number	10/687,562
		Filing Date	10/16/2003
		First Named Inventor	Cherala, et al.
		Group Art Unit	Unassigned
		Examiner Name	Unassigned
Sheet 2 of 2	Attorney Docket Number	PA61/UTS-35-01-03	

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cita No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
<i>AW</i>	A7	CHOU et al., "Imprint of Sub-25 nm Vias and Trenches in Polymers," Applied Physics Letters, November 20, 1995, pp. 3114-3116, vol. 67(21).	
<i>AW</i>	A8	CHOU et al., "Imprint Lithography with 25-Nanometer Resolution," Science, Apr. 5, 1996, pp. 85-87, vol. 272.	
<i>AW</i>	A9	MANSKY et al., "Large-Area Domain Alignment in Block Copolymer Thin Films Using Electric Fields," Macromolecules, 1998, pp. 4399-4401, vol. 31.	
<i>AW</i>	A10	CHOU et al., "Lithographically-Induced Self Assembly of Periodic Polymer Micropillar Arrays," Journal of Vacuum Science and Technology, Nov/Dec 1999, pp. 3197-3202, vol. B 17(6).	
<i>AW</i>	A11	WILLSON et al., "Method and System for Fabricating Nanoscale Patterns in Light Curable Compositions Using an Electric Field," U.S. Patent Application 09/905,718, Filed with USPTO on May 16, 2002	
<i>AW</i>	A12	SREENIVASAN et al., "Method and System for Imprint Lithography Using an Electric Field," U.S. Patent Application 10/194,410, Filed with USPTO July 11, 2002.	

Examiner Signature	<i>Alan Olson</i>	Date Considered	6-26-05
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